



501.36694CV4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. SHUKURI, et al.  
Application. No. 10/635,511  
Filed: August 7, 2003  
For: SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE HAVING  
DEPOSITED LAYER FOR GATE INSULATION  
Group: 2814  
Examiner: Long Pham  
Confirm. No.: 8446

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR §§ 1.97 & 1.98

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

November 23, 2005

Sir:

Pursuant to Applicants' duty of disclosure, enclosed please find copies of documents recently furnished in connection with a corresponding Korean Application. Also enclosed is a copy of an Official Action from the Korean Patent Office and English translation thereof, citing the aforementioned documents; and English abstracts of the aforementioned documents (which are Japanese laid-open applications). Further enclosed is a Form PTO/SB/08A&B, listing the enclosed documents.

This Information Disclosure Statement is being submitted in an application under Final rejection. For satisfying requirements of 37 C.F.R. 1.97(d), the necessary fee under 37 C.F.R. 1.17(p) is enclosed, and the following Statement is made under 37 C.F.R. 1.97(e):

Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to the filing of this Information Disclosure Statement.

To the extent that the above-listed documents are not in English, the requirements of 37 C.F.R. 1.98(a)(3) are satisfied at least by the enclosed English translation of the enclosed Office Action, as well as by English abstracts of the cited Japanese patent documents.

In view of the foregoing, it is respectfully submitted that all applicable requirements of 37 CFR §§ 1.97 and 1.98 have been satisfied, in connection with the documents listed on the enclosed Form. Accordingly, consideration of the listed documents, upon further examination of the above-identified application, is respectfully requested.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Docket No. 501.36694CV4), and please credit any excess fees to such deposit account.

Respectfully submitted,

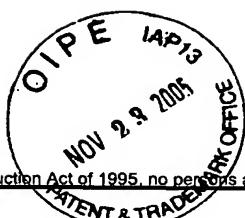
ANTONELLI, TERRY, STOUT & KRAUS, LLP

By



William I. Solomon  
Reg. No. 28,565

WIS/gjb  
1300 North Seventeenth Street, Suite 1800  
Arlington, Virginia 22209  
Telephone: (703) 312-6600  
Facsimile: (703) 312-6666



PTO/SB/08A (10-01)

Approved for use through 10/31/2002. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

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 Substitute for form 1449A/PTO		Complete if Known			
		<b>Application Number</b>	10/635,511		
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>		<b>Filing Date</b>	August 7, 2003		
<i>(use as many sheets as necessary)</i>		<b>First Named Inventor</b>	S. Shukuri, et al.		
		<b>Art Unit</b>	2841		
		<b>Examiner Name</b>	Long Pham		
		<b>Attorney Docket Number</b>	501.36694CV4		
Sheet	1	of	1		

## U.S. PATENT DOCUMENTS

## FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS					
Examiner Initials'	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code <sup>3</sup> –Number <sup>4</sup> –Kind Code <sup>5</sup> (if known)			
		JP 06-61499	03-04-1994	Mitsubishi Electric Corp.	
		JP 08-204142	08-09-1996	Oki Electric Ind. Co. LTD	

## OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS

SEARCHED - EXAMINED - NOT PATENT - EXTERNALE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		Korean Office Action, dated September 30, 2005, Application No. 10-1998-0053407	

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language Translation is attached.

**Burden Hour Statement:** This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.